



PATENT
Docket No.: Q106-US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: :
Hisashi Tsukamoto et al. :
Application No.: 10/031,022 : Group Art Unit: 1734
Filing Date: January 14, 2002 : Examiner: N/A
Title: LITHIUM THIN FILM :
LAMINATION TECHNOLOGY :
ON ELECTRODE TO INCREASE :
BATTERY CAPACITY :

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Dated April 23, 2003

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